PATENT SPECIFICATION

(11)

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(21) Application No. 41144/77
(31) Convention Application No.

(22) Filed 4 Oct. 1977 (32) Filed 4 Oct. 1976 in

729227
(33) United States of America (US)

(44) Complete Specification published 11 April 1979

(51) INT. CL.2 H01L 23/00

(52) Index at acceptance
H1K 5B1 5B2 5D9 PX C3T 6F1 6J3C

(54) ELECTRICAL DEVICE AND METHOD OF MAKING SAME

(71) We, OWENS-ILLINOIS INC., a corporation organized and existing under the laws of the State of Ohio, United States of America, of Toledo, State of Ohio, United States of America, (Assignee of RAYMOND LOUIS DIETZ and JAMES JOSEPH TILLMAN), do hereby declare the invention, for which we pray that a patent may be granted to us, and the method by which it is to be performed, to be particularly described in and by the following statement:-

The present invention relates to electrical devices and to their manufacture and more particularly relates to improved die attach resters.

The art is aware of electrical devices, for example DIPs in which a die, i.e. a silicon chip which carries an integrated circuit on an upper portion thereof, is adhesively bonded to an electrically insulative support by means of epoxy resins, the latter means being commonly referred to as a die-attach. The epoxy resins which are usually applied by, for example, screen printing techniques may include

25 effective filling amounts of inorganic fillers.

The present invention is directed to improved electrical devices of the type described above wherein the die attach means comprises the product obtained by heat 30 cuting a solvent-soluble further-curable organopolysiloxane consisting essentially of the hydrolysis and partial condensation product obtained by a process comprising: Heating a silane of the formula CH₂Si(OR)₃, or a silane of the formula CH₂Si(OR)₃, and C₆H₈Si(OR)₃ in a mole ratio of the latter to the former of between 1:10 and 10:1, wherein R is an alkyl of 1-6 carbon atoms, with water in an amount of 1.5 to 10 moles of water per mole of total silane, and in the presence of an effective catalytic amount of an acid hydrolysis catalyst, from 1 to 10 hours between ambient up to, and including, the reflux temperature to form a solution of a hydrolyzed, siloxane partial condensation

product; and concentrating the solution by heating to remove some but not all volatile material including alkanol by product and water so as to obtain a solution of a hydrolyzed further partially condensed, solvent-soluble organopolyziloxane. Suitably the concentrating will be done to produce a solids content of about 62% to about 75% by weight.

by weight.
Preferably, the solvent-soluble further-55 material which is produced by precuring the concentrated solution of the hydrolyzed, further partially condensed, solvent-soluble organopolysiloxane by heating below the 60 gel point thereof and then solidifying, as by flaking, the resultant liquid solvent-soluble further-curable organopolysiloxane. These organopolysiloxanes are available commercially and may be manufactured in accordance with the teachings of U.S. Patent Nos. 3,389,121, 3,389,114 and 3,414,540 all of which are hereby incorporated by reference. A particularly suitable organopolysiloxane is the solvent-soluble further-curable organopolysiloxane produced from a mixture of phenyltriethoxysilane and methyltriethoxysilane wherein the molar amount of the former is greater than the molar amount of the latter, with an especially suitable molar ratio being about 4:1. Quite outstanding materials will be obtained by heating, to effect hydrolysis and partial condensation, a mixture of about 2-3 moles of water per mole of total silane, and about 1-10 parts per million of HCL based on the combined 80 weight of water and sliane.

in a preferred embodiment of this invention the means for bonding the silicon chip to the support will also include the product obtained by heat curing the heat-curable solvent-soluble organopolysiloxane in admixture with effective filling amounts of particulate inorganic fillers. Preferably the fillers will be of a size less than about 35 microns. These fillers may take the form of being at least one

PAGE 12/15

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metal preferably, copper, iron, or nickel which will be employed in an effective thermal conductivity enhancing amounts, i.e. they will be employed in amounts sufficient to 5 enhance the removal of heat when the electrical device is operated and/or the inorganic fillers may include effective thermal stabilizing amounts and effective thermal expansion adjusting amounts of such inorganic 10 fillers as refractory oxides, minerals, clays and diatomaccous earth. Exemplary of such suitable fillers, which not only may serve to adjust the thermal expansion of the bonding means to be compatible with the silicon chip 15 and support but which also may be employed to adjust the consistency, or viscosity, of the material, as applied, to be compatible to the particular method of application, are such fillers as mice, aluminium 20 silicate, titania, aluminium oxide, silicon dioxide, zirconium oxide, zircon, magnesium oxide, spinel, calcium, magnesium or zinc carbonates, or silicates, and the like. Preferably the weight ratio of the inorganic 25 fillers to the organopolysiloxane will be less than about 9:1 and usually, when employed, the fillers will be present in a weight ratio to the organopolysiloxane of at least about 3:7. While generally there will be no need to do 30 so, if desired, the material which is applied for bonding the silicon chip to the support may include effective cure promoting amounts of a cure promoter. Preferably such promoters include phenylphosphonic acids, amine compounds, for example, gamma aminopropyl-tricihoxysilane, and methylated and isobutylated melamine formaldehyde partial condensate resins, as generally set forth in U.S. Patent No. 3,935,346 which is hereby incorporated by reference. Usually the amount of the cure promoter will be about 15% by weight, or less, based on the organopolysiloxane. If desired primers may be employed on either the silicon chip or the support but generally this will not be necessary. Exemplary of suitable primers include the thermoset acrylics and

aminosilanes as generally set forth in U.S.
Patent Nos. 3,707,397 and 3,650,808.
Some of the advantages of the present 50 invention are that the composition which is employed to bond the silicon chip to the electrically insulative support has a long pot life, it is a one part system, unlike the epoxy system, it is curable in short periods of time, 55 no out-gassing results upon utilization and is capable of withstanding temperatures up to around 400°C, it is non-reactive with the surroundings, is non-flammable, and can be conveniently, expeditiously and economically employed.

The organopolysiloxanes contemplated herein have been used as coatings on such materials as plastics, metals and glass. In this respect reference may be had, for example, to U.S. Patents 3,451,838, 3,457,221 and 3,460,980. Additionally they have been

employed to produce laminates, and, in this respect reference may be had to U.S. Patent No. 3,654,058. None of these patents, however, are directed to forming electrical devices as contemplated herein.

The composition which is applied to the electrically resistive support is applied in a substantially anhydrous carrier, which is an organic solvent for the solvent-soluble further-curable organopolysiloxane. A wide variety of solvents will be routinely solected but particularly suitable solvents are those sold under the tradename "Carbitol", or under the tradename "Ccllosolvo", or mixtures thereof. Generally the solvents are 80 conventional organic polar solvents, e.g. alkanols, ketones, ethers and esters. Particularly suitable are diethyleneglycol monobutylether acetate and ethylonegiyool monobutylether or mixtures thereof. When employed the fillers will be simply admixed with the solvent solution of the organopolysiloxane. 85 The composition may be applied by conventional techniques, with screen printing being especially highly preferred. When 90 employing screen printing in addition to the organopolysiloxane and the solvent therefor the composition will preferably include an amount of inorganic fillers which is sufficient to adjust the viscosity, or consistency, of the 95 material so as to make it conducive to being applied by screening. Usually a viscosity of about 200,000 cps. will be quite suitable for this purpose. Obviously if effective curs promoting amounts of a cure promoter are employed they may be added in any 100 suitable manner into the composition.

After being applied to the support the composition is usually slightly heated to evaporate the solvent but the heating is 105 insufficient to cure the further-curable organopolysiloxane; then the die, or silicon chip, having the integrated circuit is applied to the residual material and then subsequently the assembly is heated for a time and at a tempera- 110 ture sufficient to cure the organopolysiloxane to a thermoset condition. Suitable results will be obtained by generally employing a heating cycle in which the temperature is between about 160°C, to about 250°C for a period of time of 115 between about 15 or 30 seconds to about 10 or 15 minutes. After the material has been screen printed onto the electrically insulative support, i.e. into the recess 11, quite conveniently the procedure thereafter will 120 be employed using a die attach apparatus applied commercially by Unitee Die Bonder as their Model 8140-04-12. While the above sets forth the present invention to enable those skilled in the art to make and use same there

nonetheless follows further exemplification. The invention will now be further described by reference to the drawing which schematically illustrates an embodiment of this

Referring to the drawing the embodiment

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	mustrates a portion of an electrical package
	commonly referred to in the art as a DIP. This
	Package comprises an electrically insulative
	Of registive, support generally designated to
	IMPICALLY TORMED OF An inorganic material such
	as a commic, for example aluming or baryling
	which is provided with a central recess 11.
	Disposed at the lower surface of recess 11 is
	the product 12 obtained by heat curing the
1	O solvent-soluble further-curable opposite
•	
	siloxane as contemplated herein. This organo-
	Purysiloxane serves to adhesively hand the
	miget siltings of the silicon chin, generally
_	designated 13, having an integrated circuit
Į	arrefront to amport in the sees it
	Simplifiedly and schematically, the
	integrated circuit is represented by the general
	raised grid portions 13a which represents
	the circuitry interconnecting diffused
20	o circuitry in the silicon chip, e.g. N and/or P
	regions, formed in the silicon chip.
	EXAMPLE I
	A solvent-soluble further-curable organo-
	polysiloxane which is commercially available
25	a a laked solid from Owens Winnie Inc
	under their designation Type 908 was
	employed. This material is a solidified
	solvent-soluble further-curable organopoly.
	suoxane manufactured from a mixture of
30	PREMYITTIETHOXYSILING and methyltriethovy
	Sliane in a molar ratio of about 4:1 (former
	to the latter). The silanes are hydrolyzed and
	condensed by employing about 2-3 parts par
	million, based on the total weight of silane
35	and water, of HC1 and between about 2-3
	moles of water per mole of total silane.
	Generally the material is produced in
	accordance with the teachings of U.S. Patent
	No. 3,414,540. The solvent-soluble further-
40	curable organopolysiloxane was then
•	dissolved in diethyleneglycol monobutylether
	accrate to a colide concentration of the concentration
	ncetate to a solids concentration of about 70%
	by weight. To this solution copper powder
45	(generally having a particle size of about 20
10	microns) was added in a weight ratio of about
	8:1 to about 8.5:1 based on organopoly-
	siloxane solids. The material was intimately
	mixed to produce a paste and this paste was
50	then screened into the recess of an alumina
20	support conventionally used in the production
	of DIP electrical devices. The paste was applied
	using a 165 mesh screen and was then dried at
	about 100°C. for 7-10 minutes. The alumina
55	support with the residual bonding material
23	was then placed on a heater block which was
	preheated to about 160°C, and was allowed
	to remain there for about 5-10 seconds and
	then the silicon chip was rubbed into the
co	paste over a period of about 2-3 seconds. The
60	unit with the silicon chip having the integrated
	circuit, which chip is in intimate content
	With the further-curable organopolygiosana
	composition, was then heated at a
<i></i>	temperature of about 160°C. for about 10

65 minutes whereby the organopolysiloxane

_		
	became thermoset and provided excellent	
3	Donding of the silicon this into the recess	
	or the electrically insulative ceramic.	
	While the foregoing describes the present	
٠	invention it will be, of course, apparent that modification is possible which pursuant to	70
	the patent laws and statutes do not depart	
	from the spirit and scope thereof	
	WHAT WE CLAIM IS:	
	1. An electrical device comprising an	75
	electrically insulative support, a silicon chia	,,
	carrying an integrated direult and means for	
	bonding said chip to said support, said means	
	comprising the product obtained by heat	
	curing a solvent-soluble, further-curable organopolysiloxane consisting essentially	80
	of the hydrolysis and partial condensation	
	product obtained by a process comprising:	
	heating a silane of the formula CH_Si(OR)s,	74
	a mixture of silance of the formula	85
	CH ₂ Si(OR) ₂ and C ₄ H ₄ Si(OR) ₂ in a mole	03
	ratio of the latter to the former of herwern	
	1:10 and 10:1, wherein R is an alkyl of 1-6	
	carbon atoms, with water in an amount of	
	1.5 to 10 moles per mole of total silane,	90
	and in the presence of an affective catalytic	
	amount of an acid hydrolysis catalyst, from 1 to 10 hours between ambient up to, and	
	including, the reflux temperature to form a	
	solution of a hydrolyzed siloxane partial	
	condensation product and concentrating the	95
	solution by heating to remove some but not	
	all volatile material including alicanol by	
	product and water so as to obtain a solution	
	OI a nydiolyzed, further partially	100
	condensed solvent-soluble organopoly-	X V V
	silokane.	
	2. A device as claimed in claim 1, in	
	which R is ethyl,	
	3. A device as claimed in claim 1 or 2	105
	in which said means further includes the	
	product obtained by heat curing said organo-	
	polysiloxane in admixture with effective filling amounts of inorganic fillers.	
	4. A device as claimed in claim 3 in	
	which said filler comprises effective thermal	110
	conductivity enhancing amounts of at least one	
	thermally conductive metal.	•
	5. A device as claimed in claim 3 or 4	
	in which the weight ratio of filler to said	115
	organopolysiloxane is less than about 9:1.	
	6. A device as claimed in claim 3, 4 or	
	5, in which sald filler comprises effective	
	thermal stabilizing amounts and effective thermal expansion adjusting amounts of	
	inorganic fillers.	120
	7. A device as claimed in any one of the	
	preceding claims, in which said means to the	
	Ploguct obtained by heat curing and armore	
	polysuoxane in the presence of offection aven	125
	conducing anomits of a cure promoter	143
	 A device as claimed in claim 1 	
	Substantially as hereinbefore described with	
:	reterence to, and as illustrated in the	
1	accompanying drawing	130
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concentrating the solution by heating to

Liverpool L1 3AB.

Chartered Patent Agents.

1 544 056 4 9. A device as claimed in claim 1 remove some but not all volatile material substantially as hereinbefore described in the including alkanol by product and water so as to obtain a solution of a hydrolyzed, further foregoing Example. 10. A method for manufacturing an selectrical device which comprises applying a material to an electrically insulative support. 30 partially condensed solvent-soluble organopolysiloxane. 11. A method as claimed in claim 10, in which said material further includes in material to an electrically insulative support, said material being capable upon application of heat of bonding a silicon chip carrying an integrated circuit to said support, said 10 material comprising a solvent-soluble further-curable organopolysiloxane constituit of the hydrolysis and partial condensation are dust obtained by a process. admixture with said solvent-soluble further-35 curable organopolysiloxane effective filling amounts of inorganic fillers. 12. A method as claimed in claim 10, in which said material further includes effective sation product obtained by a process cure enhancing amounts of a cure promoter.

13. A method as claimed in claim 10, substantially as hereinbefore described with sation product obtained by a process comprising: heating a silane of the formula 15 CH₃SI(OR)₃ or a mixture of silanes of the formula CH₃Si(OR)₃ and C₆H₃Si(OR)₃, in a mole ratio of the latter to the former of between 1:10 and 10:1, wherein R is an alkyl of 1-6 carbon atoms, with water in an amount of 1.5 to 10 moles of water per mole of total silane and in the presence of an effective catalytic amount of an acid bydrolytic reference to, and as illustrated in the accompanying drawing.

14. A method as claimed in claim 10, substantially as hereinbefore described in the foresping Francia. 45 foregoing Example. catalytic amount of an acid hydrolysis catalyst from 1 to 10 hours between ambient up to, and including, the reflux temperature to form a solution of a hydrolyzed siloxane partial condensation product and W.A. THOMPSON & CO., 50 Coopers Building, Church Street,

Printed for Her Majesty's Stationery Office by MULTIPLEX techniques Itd., St Mary Cray, Kent. 1979. Published at the Patent Office, 25 Southampton Buildings, London, WC2 1AY, from which copies may be obtained.

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COMPLETE SPECIFICATION

1 SHEET

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